IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INVENTOR(S) : Cochran et al.

TITLE : PATTERNED ILLUMINATION METHOD

AND APPARATUS FOR MACHINE

VISION SYSTEMS

APPLICATION NO. : 10/519,180

FILED : August 18, 2005

CONFIRMATION NO. : 5253

EXAMINER : Luu, Thanh X.

ART UNIT : 2878

ATTORNEY DOCKET NO. : PSSZ 2 00073

RESPONSE TO INTERVIEW SUMMARY

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Applicants gratefully acknowledge receipt of the Interview Summary for the telephone interview of September 21, 2007.

As indicated therein, Joseph D. Dreher and Thanh X. Luu participated in a telephonic interview and discussed the prior art and the claims. The Examiner maintained his rejections.

No agreement was reached. However, Applicants filed a Request for Continued Examination on September 26, 2007.

In accordance with the instructions provided in the Interview Summary, it is respectfully submitted that the present response fulfills the requirement to file a statement of the substance of the interview.

Respectfully submitted,

FAY SHARPE LLP

Chuhan 25, 2007

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CERTIFICATE OF ELECTRONIC TRANSMISSION

I hereby certify that this paper and/or fee is being transmitted to the USPTO by electronic transmission via EFS-Web on the date indicated below.

Roseanne Giuliani

Date: Oct 25, 2007